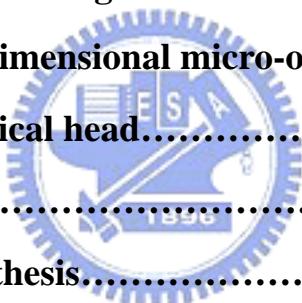


Contents

Chapter 1

Introduction

1.1 Optical path in rewritable system.....	3
1.2 The development of pick-up head.....	5
1.2.1 Micro-opto-electric-mechanical-systems (MOEMS)	5
1.2.2 Integrated-optic implementation based on waveguides and holographic (diffractive) components.....	6
1.2.3 Planar pickup based on glass substrate light guide.....	8
1.2.4 Free space three dimensional micro-optical bench.....	9
1.3 Planar fiber-base optical head.....	10
1.4 Research objective.....	11
1.5 Organization of this thesis.....	11



Chapter 2

Principle

2.1 Introduction.....	12
2.2 Fiberlens.....	12
2.3 Solid immersion lens (SIL) system.....	15
2.4 Si bulk micromaching.....	19
2.5 Summary.....	23

Chapter 3

Simulation

3.1 Introduction.....	24
3.2 Optimizing Process.....	25
3.2.1 Fiberlens.....	26
3.2.2 Fiberlens & Solid Immersion Lens.....	29
3.3 Dimension & Alignment tolerance analyses.....	34
3.3.1 Radius of Fiberlens.....	34
3.3.2 Thickness of SIL.....	36
3.3.3 Alignment tolerance.....	37
3.4 Summary.....	41



Chapter 4

Fabrication and Measurement

4.1 Introduction.....	42
4.2 Fabrication.....	42
4.2.1 Fabrication results.....	44
4.3 Measurement.....	46
4.3.1 Principle.....	48
4.3.2 Measurement equipments.....	50

4.3.3 Fiberlens measuring setup.....	52
4.3.4 Fiberlens & Solid Immersion Lens measuring setup.....	53
4.3.5 Measurement results.....	54
4.4 Summary.....	60

Chapter 5

Conclusion.....	61
------------------------	-----------

Reference.....	64
-----------------------	-----------



Figure caption

Fig. 1-1 Optical path for a phase-change (PC) storage system.....	3
Fig. 1-2 Optical paths for a magneto-optical (MO) storage system.....	4
Fig. 1-3 Schematic of the integrated optic disk pickup (IODPU).....	7
Fig. 1-4 Schematic of the planar optical disk pickup based on glass-substrate based: (a) side and (b) plane view.....	8
Fig. 1-5 Optical module structure.....	9
Fig. 1-6 Planar fiber-base optical head.....	11
Fig. 2-1 Illustrated schematics of the microlens on the end face of the SMF.....	13
Fig. 2-2 Hemispherical SIL focusing at the bottom surface.....	17
Fig. 2-3 (a) Super SIL and (b) the marginal ray angle approaches 90° with respect to the image space.....	18
Fig. 2-4 The diamond-type lattice can be constructed from two interpenetrating face-centered cubic unit cells. Si forms four covalent bonds, making tetrahedrons.....	21
Fig. 2-5 (100) silicon wafer with reference to the unity cube and its relevant planes.....	22
Fig. 2-6 (a) V-groove formed by the mask opened parallel to (110)-flat(b) 90° V-groove formed by the mask opened parallel to (100)-flat.....	22
Fig. 3-1 Planar fiber-base pickup head setup.....	24
Fig. 3-2 Schematics of optical module.....	25
Fig. 3-3 Optimizing process flow.....	26
Fig. 3-4 Fiberlens setup.....	28
Fig. 3-5 (a) Normal (b) Total reflection.....	28

Fig. 3-6 Fiberlens length vs. Spot size and NA.....	29
Fig. 3-7 (a) hemispherical SIL and (b) SSIL.....	30
Fig. 3-8 Absorption versus thickness of the AZ-4620.....	30
Fig. 3-9 Fiberlens and SIL setup.....	31
Fig. 3-10 Thickness of hemispherical SIL vs. effective NA & Spot size.....	32
Fig. 3-11 Thickness of SSIL vs. effective NA & Spot size @ 564um fiberlens.....	33
Fig. 3-12 Thickness of SSIL vs. effective NA & Spot size @ 700um fiberlens.....	33
Fig. 3-13 Fiberlens length vs. (a) NA and (b) Spot size.....	35
Fig. 3-14 radius of fiberlens vs. effective NA & Spot size @ 700um fiberlens.....	35
Fig. 3-15 Definition of thickness variation.....	36
Fig. 3-16 Thickness variation of SSIL vs. effective NA & Spot size @ 700um fiberlens.....	36
Fig. 3-17 Definition of three misalignments.....	37
Fig. 3-18 (a) Distance between fiberlens and SIL is smaller then focal length(b) Distance between fiberlens and SIL is larger then focal length.....	38
Fig. 3-19 Defocus vs. effective NA and spot size.....	38
Fig. 3-20 spot diagram of (a) offset Y, (b) offset X and (c) normal.....	39
Fig. 3-21 Offset vs. Efficiency.....	39
Fig. 3-22 spot diagram of (a) tilt 15 degree and (b) normal.....	40
Fig. 3-23 Angular misalignment vs. Efficiency.....	40
Fig. 4-1 Fabrication process of SIL with aperture; (a) Step 1: Deposit Ti layer, (b) Step 2: Deposit α - Si and Ni layer, (c) Step 3: Undercut Ti layer, (d) Step 4: Backside exposure and (e) Step 5: Reflow.....	43
Fig. 4-2 SEM of SIL @ aspect ratio (a) 1.25 and (b) 0.5.....	45
Fig. 4-3 $30 \mu m$ radius SIL profiles.....	46
Fig. 4-4 SEM of SIL with aperture.....	46

Fig. 4-5 Measuring System Setup.....	47
Fig. 4-6 Definition of output beam size.....	48
Fig. 4-7 Focusing a beam with a lens at the beam waist.....	49
Fig. 4-8 Focusing a collimated beam.....	50
Fig. 4-9 Intensity of ambient.....	51
Fig. 4-10 Photograph of the fiberlens measuring system.....	52
Fig. 4-11 Photograph of the fiberlens plus SIL measuring system.....	53
Fig. 4-12 Fiberlens length vs. (a) NA and (b) Spot size.....	55
Fig. 4-13 Photograph of fiberlens.....	55
Fig. 4-14 (a) $30 \mu\text{m}$ and (b) $35.2 \mu\text{m}$ radius SIL profiles.....	56
Fig. 4-15 Beam profile of $650 \mu\text{m}$ fiberlens.....	57
Fig. 4-16 Beam profile of $650 \mu\text{m}$ fiberlens with $30 \mu\text{m}$ radius SIL.....	57
Fig. 4-17 Beam profile of $650 \mu\text{m}$ fiberlens with $35 \mu\text{m}$ radius SIL.....	57
Fig. 4-18 Seidel coefficient vs. spot size ratio.....	58
Fig. 4-19 The refractive index of (a) $30 \mu\text{m}$ and (b) $35.2 \mu\text{m}$ radius SIL vs. spot size.....	59

List of tables

Table 3-1 Axial, Lateral & Angular Tolerance Compartment.....	41
Table 4-1 Dimension variation.....	45
Table 4-2 Specification of CCD camera.....	51

